

PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i> | | Application Number | |
| | | Filing Date | |
| | | First Named Inventor | Kia Silverbrook |
| | | Art Unit | |
| | | Examiner Name | |
| | | Attorney Docket Number | YU175US NP |
| Sheet | 1 | of | 8 |

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PLEASE NOTE -

* Copies not attached as previously submitted to or cited by the USPTO in parent patent nos US 6,416,167 and US 6,513,908

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| | | Group Art Unit | |
| | | Examiner Name | |
| Sheet 8 of 8 | Attorney Docket Number | | YU175US NP |

| OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS | | | |
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| Examiner Initials | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
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